



1746  
261/136-~~4~~  
P96-0015US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5/10  
6/11  
10/23/11

In re Application of: )

Group Art Unit: 1746

Eric J. Bergman )

Examiner: Z. El-Arini

Serial No. 09/811,925 )

Filed: March 19, 2001 )

For: METHODS FOR CLEANING  
SEMICONDUCTOR SURFACES )

RECEIVED

OCT 19 2001

TC 1700

AMENDMENT & RESPONSE

Commissioner for Patents  
Washington D.C. 20231

Sir:

In reply to the Official Action mailed on July 16, 2001 please amend the application as follows:

IN THE SPECIFICATION

At page 28, lines 13-14, change "as explained in the copending U.S. Patent Application Serial No. 08/607,627, filed February 26, 1996 which is hereby incorporated by reference" to --  
as explained in U.S. Patent No. 5,954,911, incorporated herein by reference. --.

A Replacement Specification sheet is enclosed.

LA-204992.1

CERTIFICATE OF MAILING  
(37 C.F.R. §1.8a)

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as First Class Mail in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231.

10/12, 2001  
Date of Deposit

Laura Murphy  
(Name of Person Mailing Paper)  
  
Signature of Person Mailing Paper